

FIG. 1A:
Vapour Deposition System

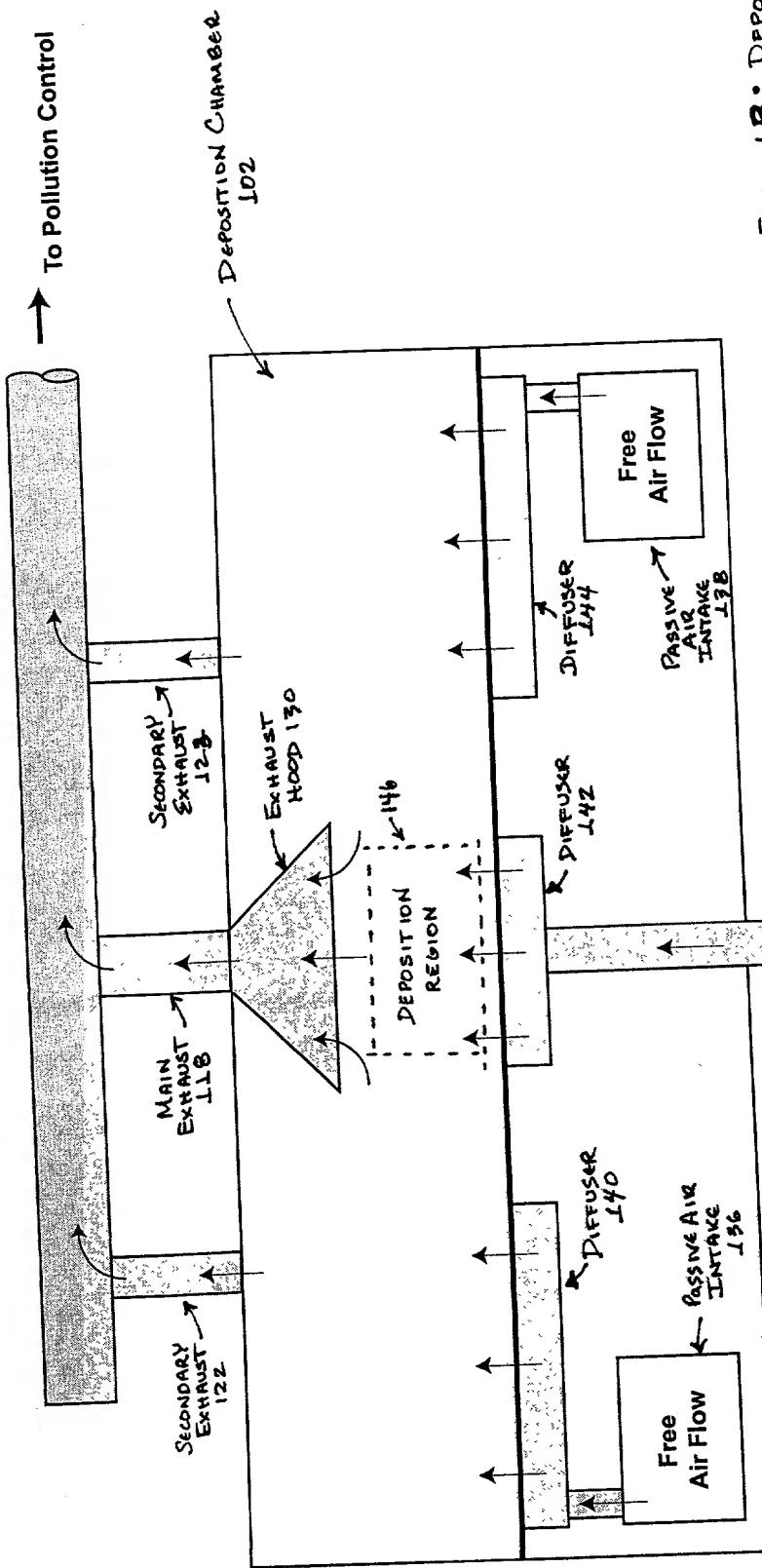
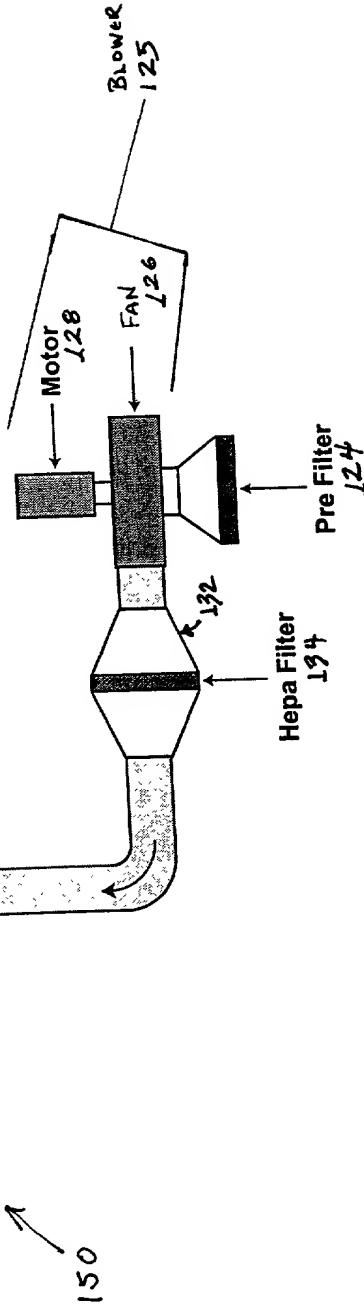


FIG. 1B: DEPOSITION CHAMBER INTAKE & EXHAUST SUBSYSTEM



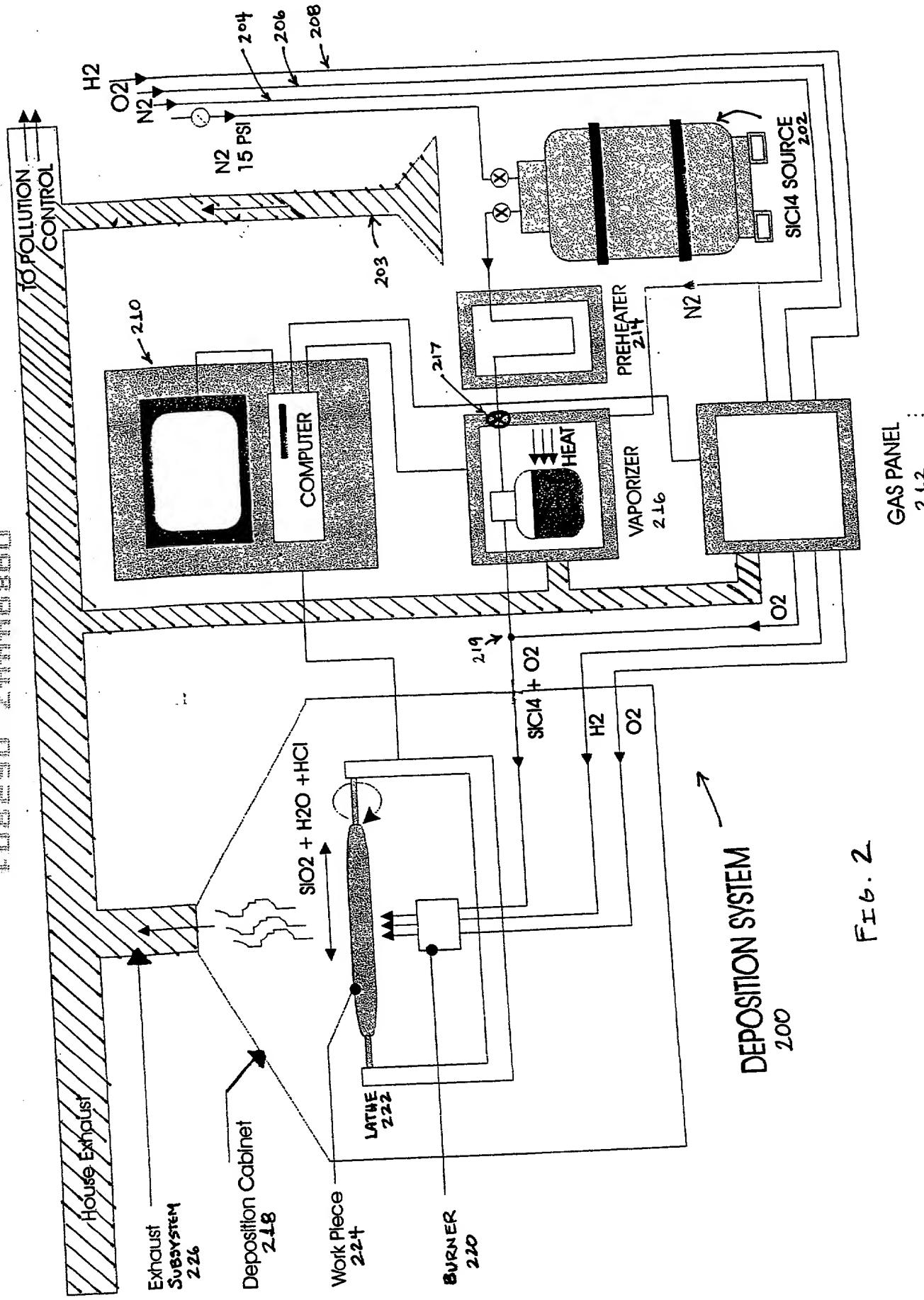
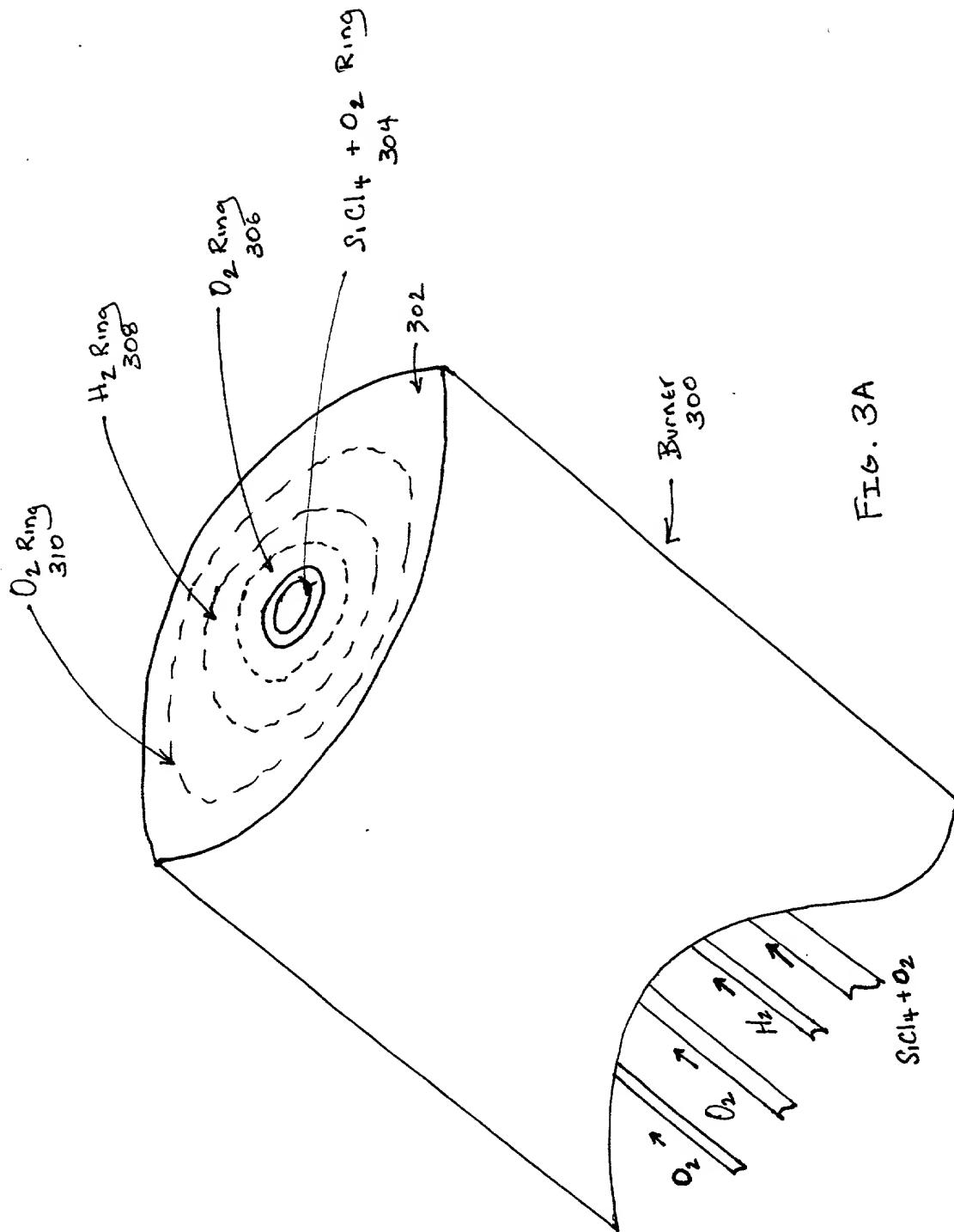


FIG. 2

GAS PANEL
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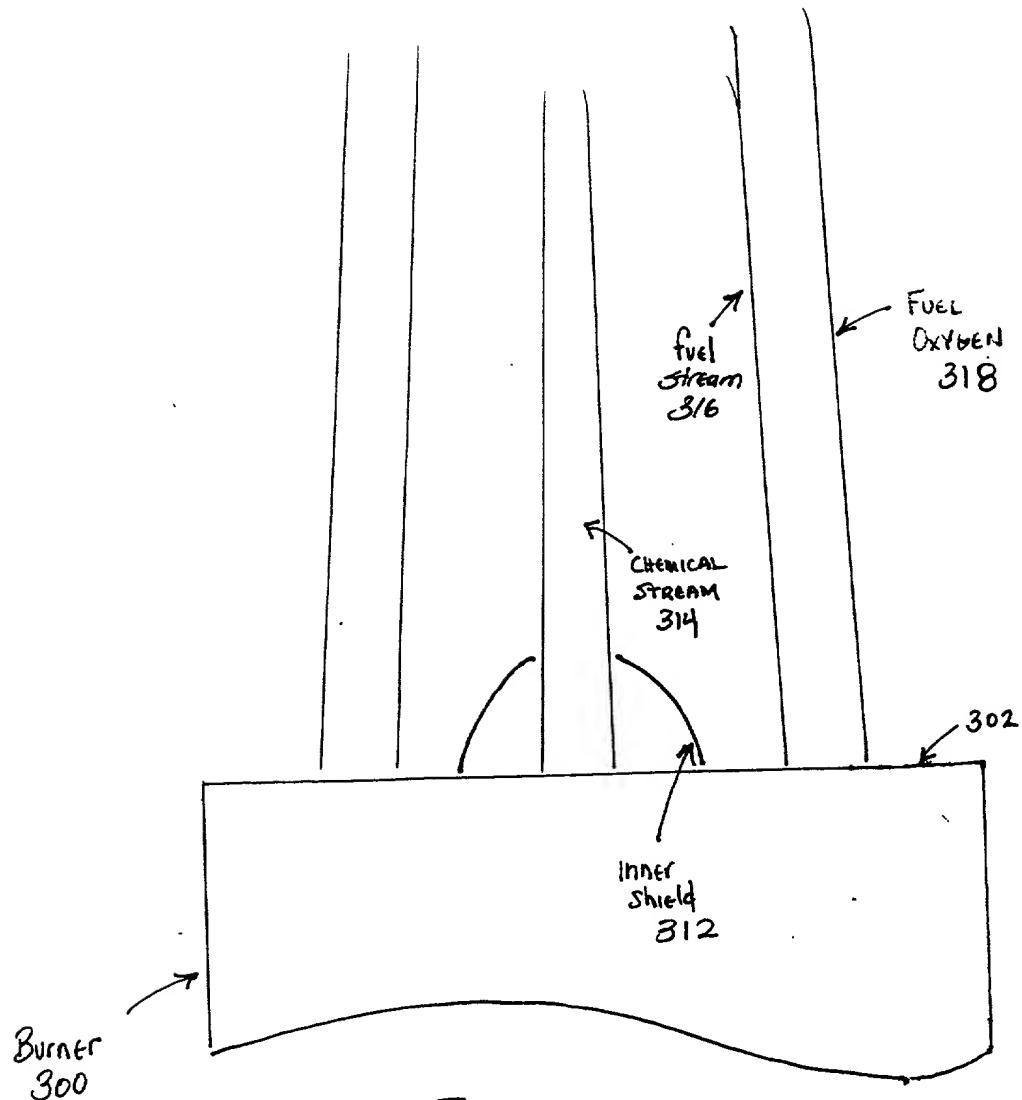


FIG. 3B

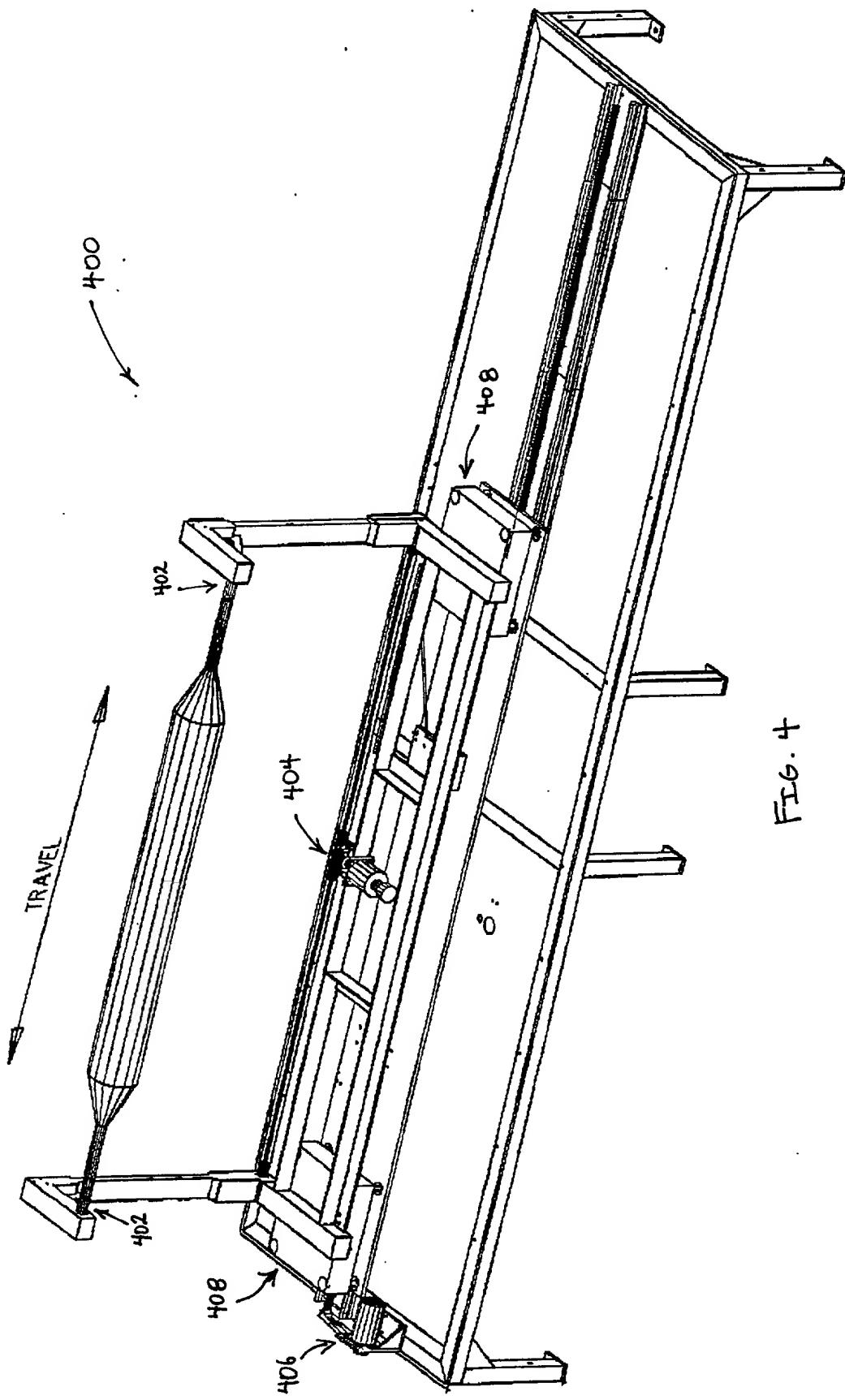


FIG. 4

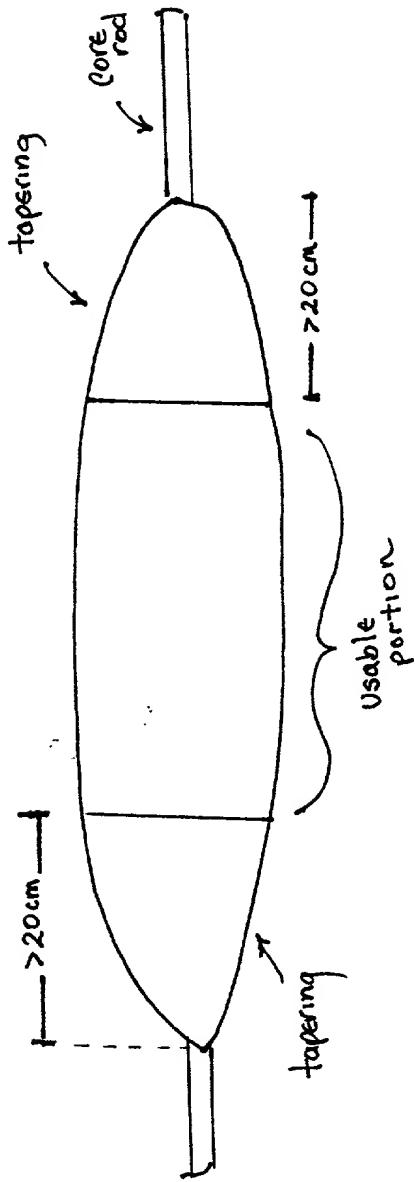


FIG. 5

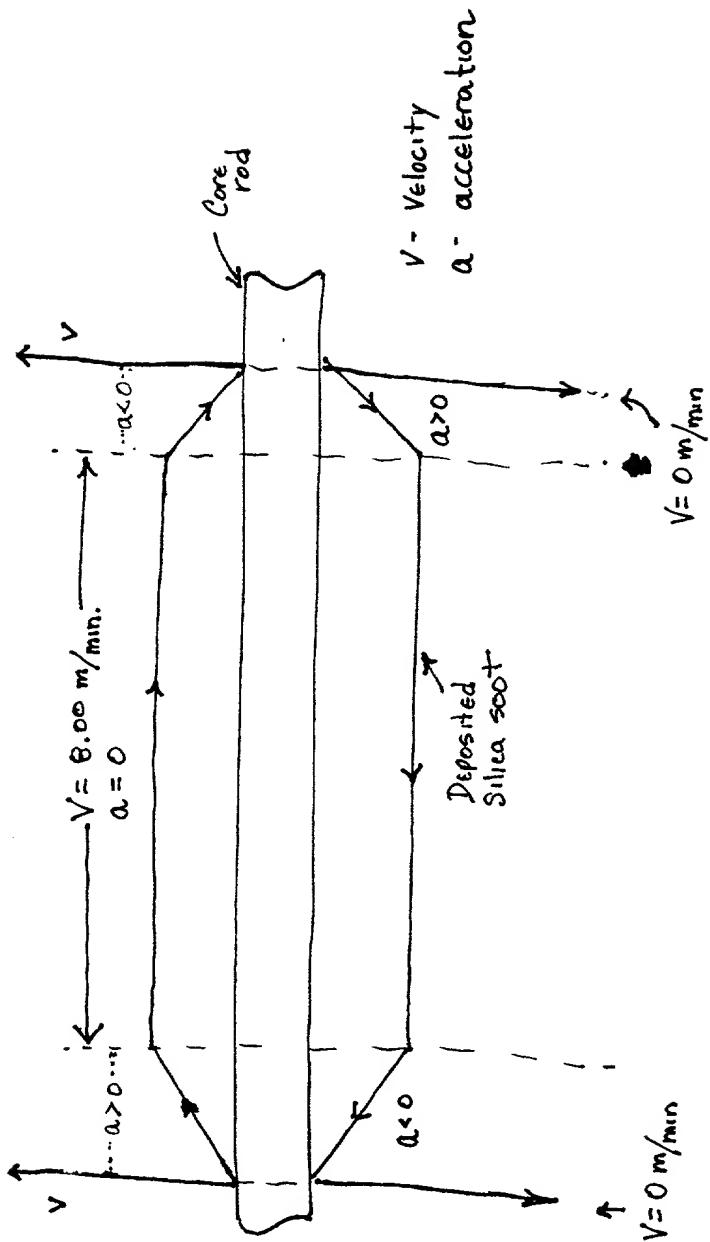


FIG. 6

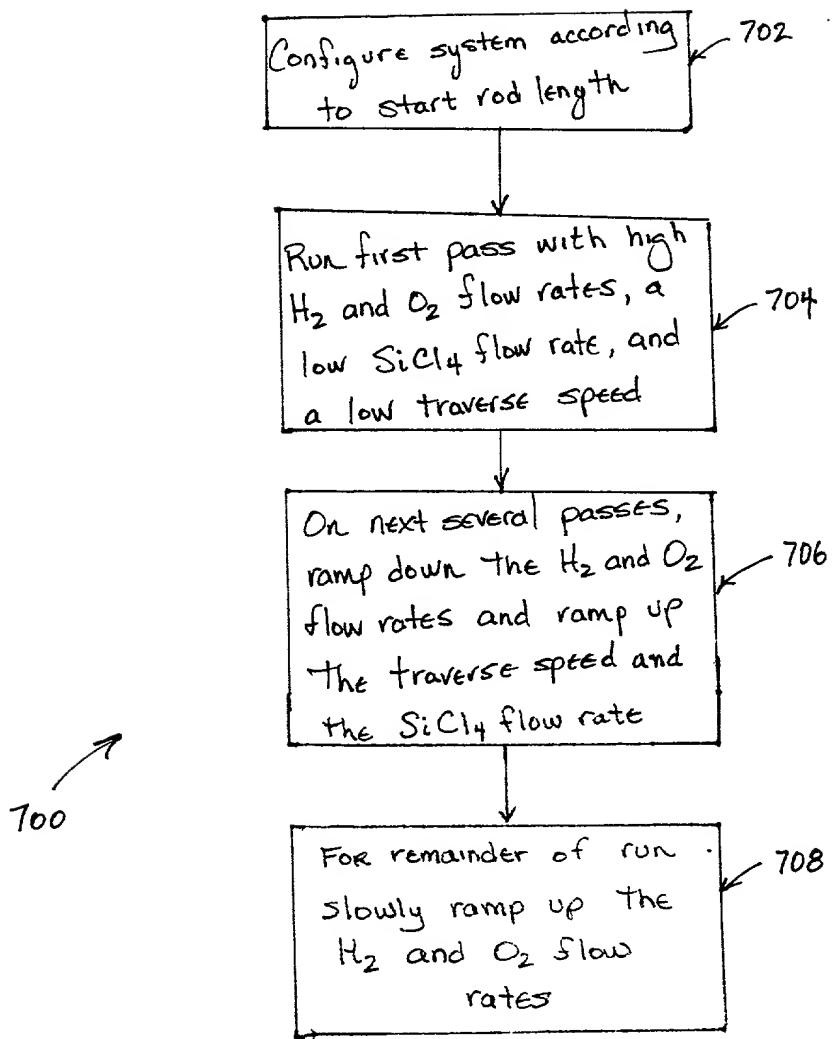


FIG. 7: DEPOSITION PROCESS